



- enrichment of gaseous  $UF_6$ .
- spectral fitting for this purpose.



$$I(\lambda) = \frac{H\omega^2}{4[(\lambda - \lambda_0)^2] - \omega^2} + C_0$$

# The Effect of Laser Pulse Width on the Behavior of UF<sub>6</sub> Plasma in LISA-UE Londrea Garrett 4<sup>th</sup> Year Ph.D. Student, University of Michigan

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### Impact and Relevance

- Improved understanding of UF<sub>6</sub> plasma behavior enables the optimization of future
- LISA-UE could greatly decrease the time
- required for enrichment facility inspection
- Improve global capabilities for <sup>235</sup>U monitoring
- Work has been performed in collaboration
- with Lawrence Berkeley National Laboratory



## **Conclusion and Future Work**

- The UI 646.49 nm continues to show promise for enrichment measurements. However, self absorption may limit accuracy.
- Future work will compare measurements performed with excitation sources of varying
- A measurement correction factor and model are under development:
  - Absorption coefficient:  $\alpha(\lambda) = \pi r_0 \lambda^2 f_{ij} n_0 P(\lambda) (1 - e^{-hc/\lambda kT})$ 
    - Voigt profile line shape:

$$L) = \int_{-\infty}^{\infty} G(\lambda) * L(\lambda - \lambda') d\lambda'$$



National Nuclear Security Administration